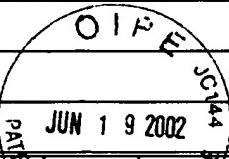


U.S. Department of Commerce, Patent and Trademark Office		Attorney Docket No.: 035-0004						
		Application No.: Unknown 10/044,744						
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)		Applicant(s): Matthew A. Simpson, et al.						
		Filing Date: January 11, 2002						
		Group Art Unit: Unknown 1775						
		Date Submitted: June 11, 2002						
U.S. Patent Documents								
*Examiner Initial	TRADEMARK OFFICE	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	JUN 18 2002 SC1	AA					TC 1700	
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Foreign Patent Documents								
							Translation	
		Document	Date	Country	Class	Subclass	Yes	No
<i>John</i>	AL	5021628 with English Abstract	01 Jan. 1993	Japan				
<i>John</i>	AM	79029380 with English Abstract	05 Mar. 1993	Japan				
	AN							
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<i>John</i>	AS	ABSTRACT of Sputter-deposited yttria-alumina thin films for optical waveguiding; Stadler BJH, Oliver M.; JOURNAL OF APPLIED PHYSICS; 84 (1): 93-99 JUL 1 1998; Document type: Article - Language: English						
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<i>[Signature]</i>	AR	ABSTRACT of Plasma-sprayed alumina-yttria ceramic coatings for cavitation-erosion protection. Kim, Hee Jae. Dep. Ordnance Eng., Korea Mil. Acad., S. Korea. Han'guk Pusik Hakhoechi (1989), 18(3), 139-46. CODEN: HPHADI ISSN: 0253-312X. Journal written in English.																																																																														
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<i>[Signature]</i>	AT	ABSTRACT No. A79034025; Authors: Korotkov, N.A.; Zaitsev, A.A.; Lazarev, E.M.; Title: Electron diffraction study of phase transformations in thin films of Y ₂ O ₃ -Al ₂ O ₃ /Al ₂ O ₃ ; Source: Izvestiya Akademii Nauk SSSR, Metally, no. 4 p. 251-5; ISSN: 0568-5303; CODEN: IZNMAQ; Publication: USSR; Translated In: Russian Metallurgy; ISSN: 0036-0295; CODEN: RMLYAQ; Country: UK; Language: English; Year: July-Aug. 1978; Record Type: Journal Paper																																																																														
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Examiner	<i>N. Lee</i>	Date Considered	<i>4/30/03</i>				
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Sheet 1 of 1
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Complete if Known
Application Number 10/044,744
Filing Date 01/11/02
First Named Inventor Simpson et al.
Group Art Unit 1775
Examiner Name (not yet assigned)
Attorney Docket Number 1035-SC4127

U.S. PATENT DOCUMENTS

Examiner Initials *	Cite No.1	U.S. Patent Document Number	Kind Code 2 (if known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
dw	AA	2001/0003271		Otsuki	6/14/01	
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PUBLICATIONS

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